

Figure 1: Fabrication diagram. The nanoscribe technology is employed for the fabrication process and it followed by analysing structure under SEM. The final stage (yellow block in third column) has not been tried in this project.

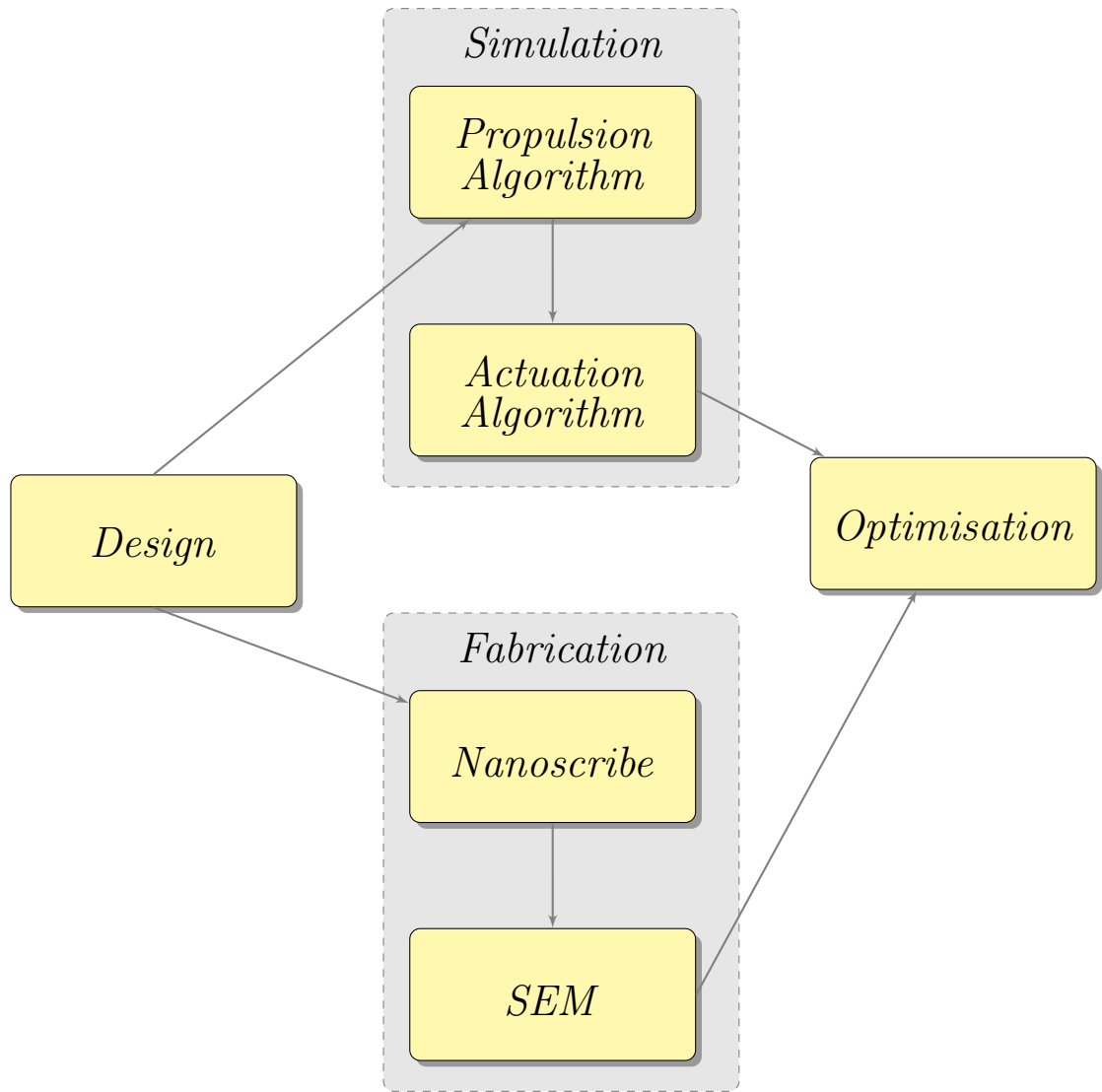


Figure 2: System Architecture.